

Impact ionization in GaAs: a screened exchange density functional approach

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Abstract

Results are presented of a fully ab-initio calculation of impact ionization rates in GaAs within the density functional theory framework, using a screened-exchange formalism and the highly precise all-electron full-potential linearized augmented plane wave (FLAPW) method. The calculated impact ionization rates show a marked orientation dependence in $\mathbf{k}$ space, indicating the strong restrictions imposed by the conservation of energy and momentum. This

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anisotropy diminishes as the impacting electron energy increases. A Keldysh type fit performed on the energy-dependent rate shows a rather soft edge and a threshold energy greater than the direct band gap. The consistency with available Monte Carlo and empirical pseudopotential calculations shows the reliability of our approach and paves the way to ab-initio calculations of pair production rates in new and more complex materials.

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Band-to-band impact ionization (I-I) is a carrier-carrier scattering process in which an energetic carrier creates an electron-hole pair through the excitation of a valence electron (e^-) in the conduction band^{1,2}. This process is fundamental in small high-speed devices, both as a charge multiplication (e.g., avalanche photodiodes) and as a detrimental mechanism (e.g., field effect transistors). We present a fully first-principles approach based on screened-exchange^{3,4} density functional theory (DFT)⁵ that allows a full understanding of the basic mechanisms and physical quantities affecting the I-I process. Our final goal is to tune the rates according to technological requirements through band structure “engineering” for simple and complex materials, without need of *ad-hoc* parameters or *pseudoatoms*.

All previous theoretical treatments have employed approximate band structures and matrix elements, based on $\mathbf{k} \cdot \mathbf{p}$, Monte Carlo (MC)^{6–8} or empirical pseudopotential (EPP)^{9–11} formalisms. To the best of our knowledge, the work herein reported is the *first fully ab-initio* calculation of I-I rates. We show results for the most studied direct gap semiconductor, GaAs. A variety of I-I results obtained through different approaches is available for GaAs, so that multiple comparisons can be made with results of the current method.

We consider an e^- -initiated I-I process (shown schematically in Fig. 1). According to Fermi’s Golden rule, the rate $r(n_1, \mathbf{k}_1)$ at which the impacting e^- in a $(n_1, \mathbf{k}_1)$ state can produce I-I is obtained as:

$$r(n_1, \mathbf{k}_1) = 2 \frac{2\pi}{\hbar} \sum_{n_2, n_3} \int d^3 \mathbf{k}_2 \int d^3 \mathbf{k}_3 |M|^2 \delta(E_{\mathbf{k}_1}^{n_1} + E_{\mathbf{k}_2}^{n_2} - E_{\mathbf{k}_3}^{n_3} - E_{\mathbf{k}_1 + \mathbf{k}_2 - \mathbf{k}_3}^{n_4}), \quad (1)$$

where n_1, n_2, n_3, n_4 are band indices ($n_i, i = 1, \dots, 7$) and $\mathbf{k}_1, \mathbf{k}_2, \mathbf{k}_3$ are $\mathbf{k}$ points in the *full* Brillouin zone (BZ). $\delta(E_{\mathbf{k}_1}^{n_1} + E_{\mathbf{k}_2}^{n_2} - E_{\mathbf{k}_3}^{n_3} - E_{\mathbf{k}_1 + \mathbf{k}_2 - \mathbf{k}_3}^{n_4})$ shows the energy conservation. The antisymmetrized screened Coulomb matrix element is obtained by adding the probabilities in the singlet and triplet states $|M|^2 = \frac{1}{2}(|M_D|^2 + |M_E|^2 + |M_D - M_E|^2)$ where M_D and M_E are *direct* and *exchange* (obtained from the direct term by exchanging final states) matrix elements. Each direct matrix element is expressed as:

$$M_D = \frac{4\pi e^2}{\Omega} \sum_{\mathbf{G}_0, \mathbf{G}_U} \delta(\mathbf{k}_1 + \mathbf{k}_2 - \mathbf{k}_3 - \mathbf{k}_4 + \mathbf{G}_0) \quad (2)$$

$$\frac{\rho_{n_3, \mathbf{k}_3; n_1, \mathbf{k}_1}(\mathbf{G}_U) \rho_{n_4, \mathbf{k}_4; n_2, \mathbf{k}_2}(\mathbf{G}_0 - \mathbf{G}_U)}{\varepsilon(q)(|\mathbf{k}_1 - \mathbf{k}_3 + \mathbf{G}_U|^2 + \lambda^2)}$$

where the δ function shows the momentum ($\mathbf{k}$) conservation and $\rho_{n_f, \mathbf{k}_f; n_i, \mathbf{k}_i}(\mathbf{G})$ is the Fourier transform of the overlap matrix of the wave functions, $\rho_{n_f, \mathbf{k}_f; n_i, \mathbf{k}_i}(\mathbf{r}) = \Psi_{n_f, \mathbf{k}_f}^*(\mathbf{r}) \Psi_{n_i, \mathbf{k}_i}(\mathbf{r})$. The subscripts i and f denote initial and final states; e is the electron charge; Ω is the unit cell volume; $q = |\mathbf{k}_1 - \mathbf{k}_3 + \mathbf{G}_U|$ is the momentum transfer and $\mathbf{G}_0, \mathbf{G}_U$ are reciprocal lattice vectors.

The interaction between valence and conduction electrons is modeled by a Coulomb potential screened through a q -dependent static model dielectric function $\varepsilon(q)^{12}$, particularly accurate for semiconductors. The interaction between conduction electrons is modeled through a Debye potential, commonly used for the screening of impurity centers in semiconductors². Both the temperature T and the carrier density in the conduction band n_0 are taken into account through an inverse Debye screening length given by $\lambda = \sqrt{\frac{4\pi n_0 e^2}{K_B T}}$, where K_B is the Boltzmann constant. Here, we used $T = 300$ K and $n_0 = 1 \cdot 10^{16} \text{ cm}^{-3}$. To carefully evaluate the matrix elements, we used accurate wave functions and band structures. In particular, to overcome the well-known shortcomings of the local density approximation (LDA) to DFT when dealing with excited states⁵, we performed self-consistent screened exchange (sX-LDA)^{3,4,13,14} calculations, as implemented within the highly precise full-potential linearized augmented plane wave (FLAPW)¹⁵ method. During the initial LDA (and the following sX-LDA) self-consistent iterations, we used a cut-off equal to 9 Ry (6 Ry) in the wave vectors and $l \leq 8$ ($l \leq 4$) inside the muffin-tin spheres chosen as $R_{MT}^{Ga} = R_{MT}^{As} = 2.3$ a.u.. The summation over the irreducible BZ was done using 4 special $\mathbf{k}$ points¹⁶.

As shown by Seidl *et al.*⁴, the sX-LDA approach can be recast within a generalized DFT formalism in which the inclusion of a non-local sX functional highly improves the description of the conduction band states compared with a bare LDA approach. This improvement is essential in the present context, since the transitions considered always involve conduction

states. The many-fold integration over the full BZ was carried out using the technique proposed by Sano and Yoshii⁹, based on a regular grid of $\mathbf{k}$ -points (with an interval length $\Delta k = (1/n)2\pi/a$, $n = 10$). As in previous investigations^{10,9}, the energy δ function is approximated by a “top-hat” function, *i.e.* as a rectangle Δ_E wide and $1/\Delta_E$ high (we used $\Delta_E = 0.2$ eV¹⁰). Spin-orbit coupling and Umklapp processes ($\mathbf{G}_0 \neq 0$) have been neglected; their inclusion in the formalism is the subject of ongoing work. We also have not considered: *i*) phonon-assisted transitions, that would relax the $\mathbf{k}$ conservation requirements among the four involved electronic states (*i.e.* $\mathbf{k}$ conservation would be satisfied through phonon participation) and *ii*) the influence of the electric field on the collision term, *i.e.* the “intra-collisional field effect”¹⁷.

The results for I-I rates initiated by electrons in the second lowest conduction band with wave vectors along [001] and [111] are shown in Fig.2. The insets show the band structure along the same symmetry lines as in the main panels. Due to energy and $\mathbf{k}$ conservation constraints, there is a marked $\mathbf{k}$ -space anisotropy in the I-I rate, that is orders of magnitude higher along [111] (Γ to L) than along [001] (Γ to X). It is noted that the second lowest conduction band in GaAs shows a decrease in energy from Γ toward X , but increases with increasing $|\mathbf{k}|$ in other directions, such as [111]. We therefore expect, and find (see Fig.2(a)), a “wave-vector anti-threshold” along the [001] axis at which I-I no longer becomes possible. Our calculated points are compared with those of other calculations¹⁰ obtained with EPP that investigated the effect on the predicted rate assuming two different band structures^{18,19}. This comparison makes clear the importance of employing an accurate band structure (such as sX-LDA FLAPW), to obtain reliable rates. The degree of agreement between these calculations and ours is reasonable, given that the band structure and some of the numerical approximations¹⁰ made in the evaluation of matrix elements differ.

The calculated I-I rates for GaAs are shown in Fig.3 (a) for processes initiated by electrons in the three lowest conduction bands vs. their impacting energy. The scattered points in the low-energy region reflect the strong anisotropy already noted: carriers with the same impacting energy but different wave vectors can have widely varying rates. However, this

anisotropy diminishes at higher energies, due to the greater ease with which $\mathbf{k}$ and energy conservation restrictions can be satisfied. Moreover, it is of interest to show an “isotropic” I-I rate, that depends only on the impacting electron energy E (solid line in Fig. 3 (a)):

$$R(E) = \frac{\sum_{n_1} \int d^3\mathbf{k}_1 \delta[E_{\mathbf{k}_1}^{n_1} - E] r(n_1, \mathbf{k}_1)}{\sum_{n_1} \int d^3\mathbf{k}_1 \delta[E_{\mathbf{k}_1}^{n_1} - E]}. \quad (3)$$

The physical reason to obtain an isotropic *energy* dependent rather than a *wave-vector* dependent rate is that in most common technological devices in which high electric fields usually are present, carriers are scattered by phonons, so as to reach similar energies, but largely different wavevectors.

Further, our E -dependent rate has been fitted using a “Keldysh-type” formula (dashed line in Fig. 3 (a)), $R(E) = P[E - E_{th}]^a$ where E_{th} is the “isotropic” threshold energy, *i.e.* the minimum energy at which the carrier is able to excite an e^- in the valence band and, therefore, to initiate I-I. Here, P, a and E_{th} have been treated as fitting parameters. An optimized linear regression procedure yields a fitted value $E_{th}^{fit} \sim 1.8$ eV, whereas our simulations indicate no ionization events for impacting energies lower than $E_{th}^{calc} \sim 1.86$ eV (considered as our “real” value for E_{th}). The excellent agreement between E_{th}^{fit} and E_{th}^{calc} provides confidence in the numerical fit. As a result, the threshold is slightly higher than the energy gap and in good agreement with the relation $E_{th} = 3/2 E_{gap}$ obtained from a parabolic band structure with constant effective masses¹. However, we believe this agreement to be fortuitous, since we have shown previously the importance of a careful treatment of band anisotropy. Moreover, it is noted that the value of E_{th} is exact within the uncertainty given by Δ_E . From the fit, we obtained $P = 3.5 \times 10^{10} s^{-1} eV^{-a}$ and $a \sim 5.8$; the high value of a reveals the “soft” character of the GaAs threshold.

In Table I and Fig. 3 (b) we compare the result of our fit with other Keldysh-type fits available from MC⁷ or EPP^{10,11} methods. Our *ab-initio* results are in overall good agreement - especially at low energies - with two of the previous works^{11,7}. While the threshold energies are within a very similar range, there are some differences in the P and a values; these can be ascribed mainly to details of band structures and numerical methods employed for evaluating

the rates (*e.g.* many-fold integration schemes).

While it would be important to compare our results with experiment, the I-I rate is not directly comparable. Rather, the quantity commonly measured is the electron ionization coefficient $\alpha(F)$ (in cm^{-1}) as a function of the applied field F . This coefficient is related to the inverse of the mean distance traveled by carrier prior to I-I; contrarily, our calculated rates (when summed with the phonon rates and normalized) give the probability (in s^{-1}) of an I-I event as a function of the carrier's energy. Therefore, the calculated I-I rates and the measured I-I coefficient are not easily related. For the experiments, we refer to Bulman *et al.*²⁰, who measured $\alpha(F)$ in (100) GaAs in a large number of different p^+n structures using avalanche noise and photocurrent multiplication: their electron ionization threshold is 1.7 eV. Therefore, the agreement with our value of ~ 1.8 eV supports the reliability of our procedure.

Finally, we offer some information about the distribution of final states, that is of great interest for transport simulations. In Fig. 4 (a), we plot the average final electron energy vs impacting electron energy along with the best linear fit. Similar to the rates themselves, the scattering of points off the straight line is evident in the low energy region. The average final electron energy is not necessarily equal, even for primary impacting electrons having the same initial energy, because of the strong restrictions imposed by $\mathbf{k}$ conservation. On the other hand, as the impacting energy increases the linear fit improves significantly. Moreover, we plot in Fig.4 (b) the percentage of transitions that involve one or both final states in the symmetry point valleys (L, Γ, X) vs the impacting electron energies. As expected, at low energy, most (even 100 % at some energies) of the transitions involve one or even both final states in the Γ valley. However, as the impacting electron energy increases, the other valleys (especially the L valley) become accessible and the final states are generally more spread over the BZ.

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TABLES

TABLE I. Fitting parameters for the rates shown in Fig. 3 (b), using the Keldysh fit formula

$$R(E) = P[E - E_{th}]^a.$$

	E_{th} (eV)	a	P (s^{-1} eV $^{-a}$)
This work	1.8	5.8	3.5×10^{10}
Ref.[11]	1.89	5.2	1.4×10^{11}
Ref.[7]	1.73	7.8	4.57×10^{10}
Ref.[10]	2.1	4.0	2×10^{12}

FIGURES

FIG. 1. Electron-initiated I-I process. The initial electrons in the conduction and valence bands are in states 1 and 2, respectively; after the transition, the final electrons in the conduction bands are in states 3 and 4.

FIG. 2. Calculated ionization rates (in s^{-1}) for impacting e^- in the second conduction band and wave vector along ((a) $\Gamma - X$ and (b) $\Gamma - L$) vs normalized wave vector (filled diamonds). The open symbols show previous results from Ref. 10. In each panel, the inset shows the band structure along the corresponding symmetry lines (the zero of energy is set to the conduction band minimum (CBM)).

FIG. 3. (a) Ionization rates (in s^{-1}) for initial e^- in the three lowest conduction bands vs their energies (the zero of energy is set to the CBM). Filled circles: wave vector dependent ionization rate $R(\mathbf{k})$; solid line: energy dependent ionization rate $R(E)$; dashed line: Keldysh fit. (b) Keldysh-type fits taken from this work (dashed bold line), Ref. 10 (thin solid line), Ref. 11 (dot-dashed line) and Ref. 7 (dotted line).

FIG. 4. Panel (a): Average final e^- energy (filled circles) vs impacting e^- energy (in eV) referred to the conduction band minimum (zero of energy). The solid line shows the best linear fit. Panel (b): Percentage of transitions that involve final states at the symmetry point (Γ (triangles), L (diamonds) and X (circles)) valleys vs impacting e^- energies (in eV).

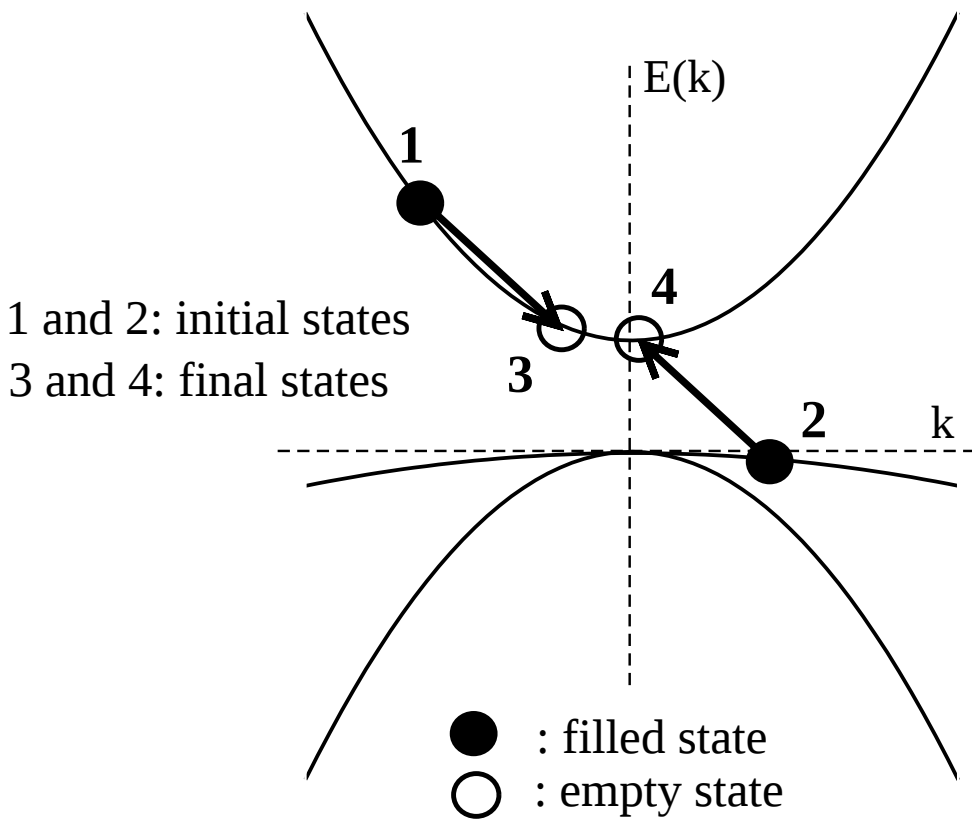


Fig. 1-Picozzi et al.

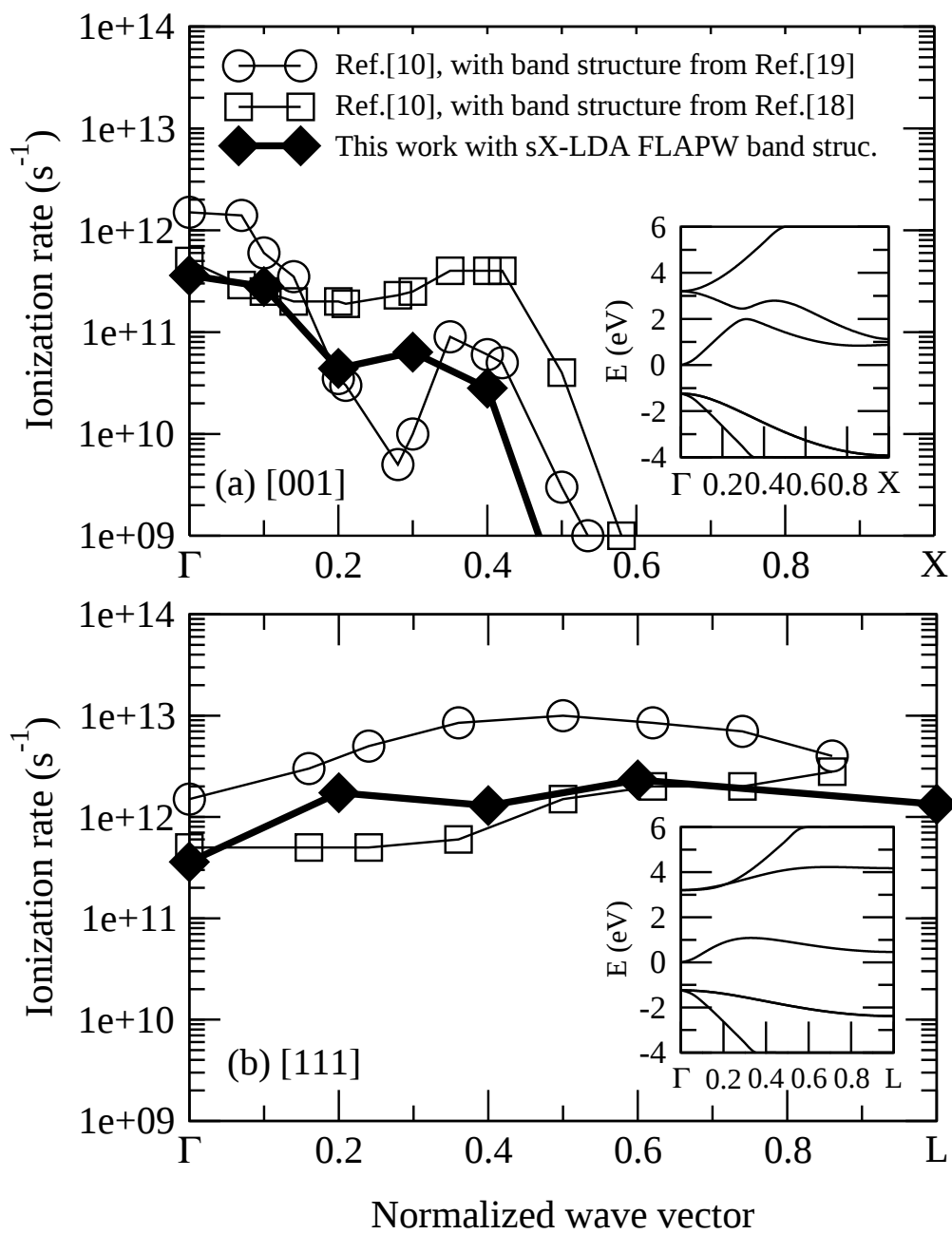
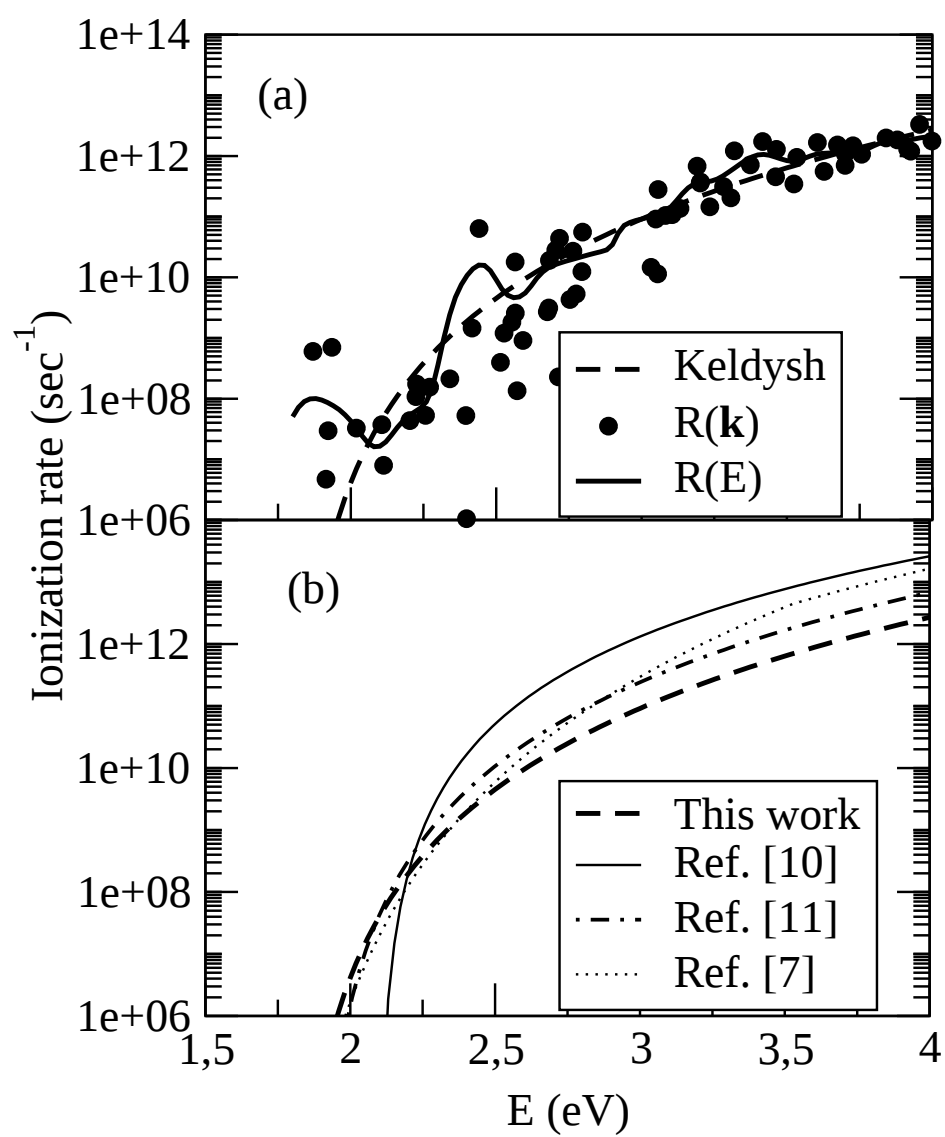


Fig.2 - Picozzi et al.

Fig. 3 - Picozzi et al.



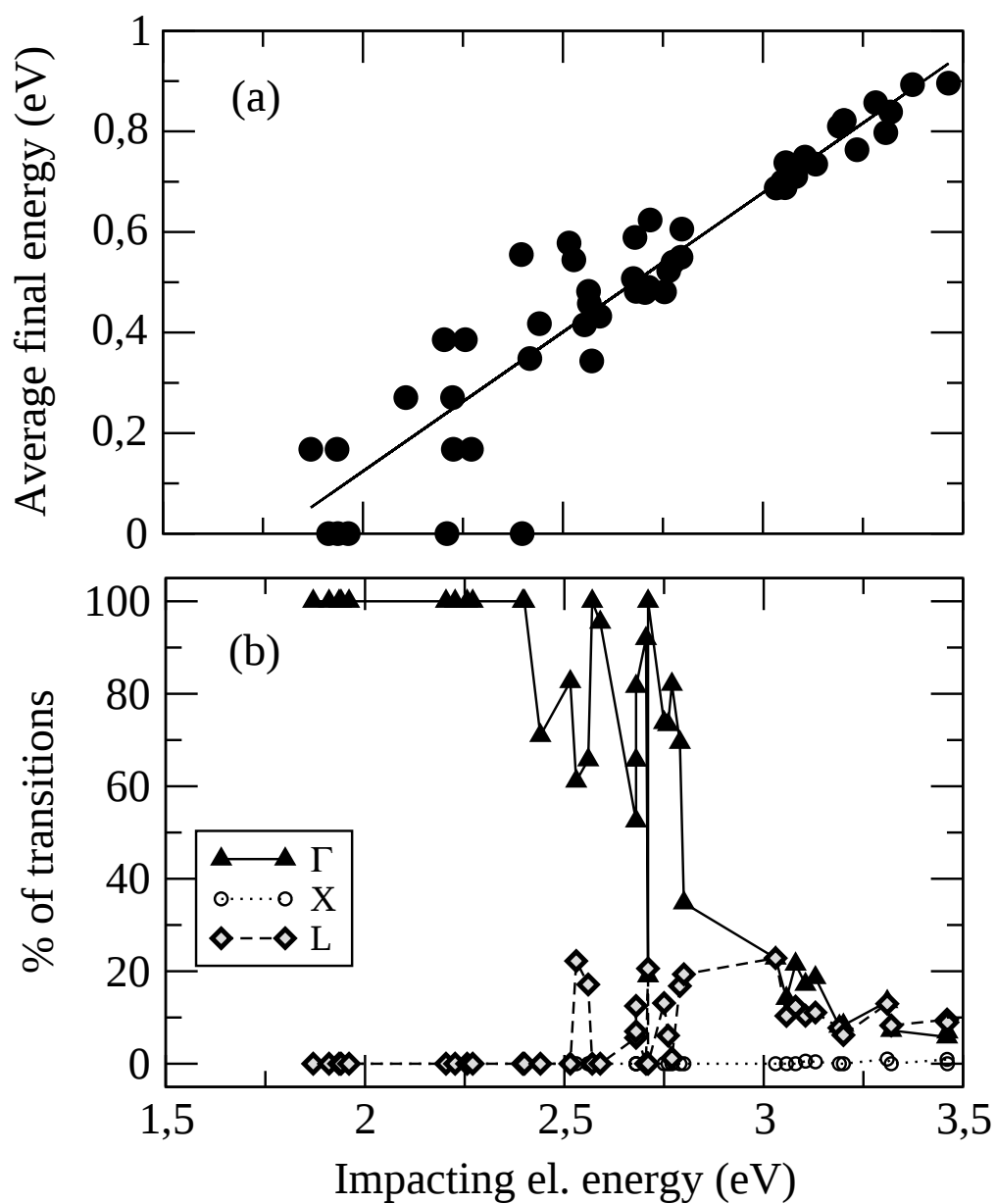


Fig. 4 - Picozzi et al.